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CONTENTS

Comparison of Laser and Oven Annealing Effects on Hydrogen and Microstructure in Thin Film Silicon	1
W. Beyer, J. Bergmann, U. Breuer, F. Finger, A. Lambertz, T. Merdzhanova, N.H. Nickel, F. Pennartz, T. Schmidt, and U. Zastrow	
p-type nc-SiO_x:H Emitter Layer for Silicon Heterojunction Solar Cells Grown by rf-PECVD	7
Henriette A. Gatz, Yinghuan Kuang, Marcel A. Verheijen, Jatin K. Rath, Wilhelmus M.M.(Erwin) Kessels, and Ruud E.I. Schropp	
Surface-initiated Group-transfer Polymerization – A Catalytic Approach to Stimuli-responsive Silicon Nanocrystal Hybrid Materials	13
Julian Kehrle, Tobias Helbich, Muhammad Iqbal, Lida Hadidi, Jonathan G.C. Veinot, and Bernhard Rieger	
Characterization of Ge_{1-x-y}Si_xSn_y Ternary Alloy Surfaces and Ni/Ge_{1-x-y}Si_xSn_y Bilayer Reactions by X-ray Techniques	19
Gordon J. Grzybowski, Arnold Kiefer, and Bruce Clafin	
1/f Noise in Mott Variable Range Hopping Conduction in p-type Amorphous Silicon	25
V.C. Lopes, A.J. Syllaios, D. Whitfield, K. Shrestha, and C.L. Littler	
Silica Nanosphere Lithography Defined Light Trapping Structures for Ultra-thin Si Photovoltaics.	31
Natasa Vulic, Jea-Young Choi, Christiana B. Honsberg, and Stephen M. Goodnick	
Passivation of Silicon Surfaces by Treatment in Water at 110°C	37
Tomohiko Nakamura, Toshiyuki Sameshima, Masahiko Hasumi, and Tomohisa Mizuno	

Observation of Superheating of Si at the Si/SiO₂ Interface in Pulsed-laser irradiated Si Thin Films	43
J.J. Wang, A.B. Limanov, Ying Wang, and James S. Im	
Composite Nanocrystalline/Amorphous Thin Films for Particle Detector Applications.	49
Zvie Razieli, Roger Rusack, and James Kakalios	
Analysis of Si-SiO₂ Interfacial-energy Hierarchy via Mixed-phase Solidification of Si Films on SiO₂	55
Ying Wang, Monica D. Chahal, J.J. Wang, A.B. Limanov, A.M. Chitu, and James S. Im	
Surface Damage Introduced by Diamond Wire Sawing of Si Wafers: Measuring in-depth and the Lateral Distributions for Different Cutting Parameters.	61
Bhushan Sopori, Srinivas Devayajanam, Prakash Basnyat, Rekha Schnepf, Santosh Sahoo, James Gee, Ferdinando Severico, Hubert Seigneur, Winston V. Schoenfeld, Steve Preece, Jeff Binns, Jesse Appel, and Kaitlyn VanSant	
Epitaxial Growth Following Crystal Nucleation in Laser-quenched Si Films on SiO₂.	67
Vernon K. Wong, A.M. Chitu, A.B. Limanov, and James S. Im	
Radial Junction Architecture: A New Approach to Stable and Highly Efficient Silicon Thin Film Solar Cells	73
S. Misra, M. Foldyna, I. Florea, L. Yu, and P. Roca i Cabarrocas	